

In re Application of: IZUO et al.
 Application No. 10/009,521
 Filed: December 11, 2001
 For: ELECTROCHEMICAL ETCHING METHOD AND APPARATUS AND PRODUCT MANUFACTURED THEREBY

Mail Stop Non-Fee Amendment
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450



RECEIVED
 OCT 28 2003
 TC 1700

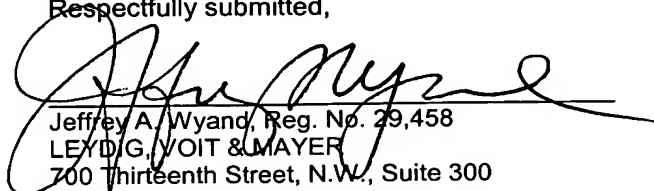
Sir:

- ☐ Small entity status is claimed for this application under 37 CFR 1.27.
- ☐ Petition for an extension of time for the period noted below, as well as for any additional period necessary to render the present submission timely. Please charge Deposit Account No. 12-1216 for the appropriate petition fee.
- ☐ Other:
- ☐ Please charge Deposit Account No. 12-1216 in the total amount indicated below. A duplicate copy of this transmittal sheet is enclosed herewith.

					SMALL ENTITY		OTHER THAN A SMALL ENTITY	
TIME EXTENSION PETITION FEE		none			\$ 0.00		\$ 0.00	
	subtract time extension fee previously paid	none			(\$ 0.00)		(\$ 0.00)	
CLAIM FEE	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	EXTRA CLAIMS PRESENT	RATE	ADDIT. CLAIM FEE	RATE	ADDIT. CLAIM FEE
TOTAL		MINUS		=0	x 9=	\$	x 18=	\$
INDEPENDENT		MINUS		=0	x 43=	\$	x 86=	\$
<input type="checkbox"/>	FIRST PRESENTATION OF MULTIPLE CLAIM				+ 145=	\$	+ 290=	\$
TOTAL AMOUNT TO BE CHARGED TO DEPOSIT ACCOUNT					TOTAL	\$	TOTAL	\$

- ☒ The Commissioner is hereby authorized to charge any deficiencies in the following fees associated with this communication or credit any overpayment to Deposit Account No. 12-1216.
- ☒ Any filing fees under 37 CFR 1.16 for the presentation of extra claims.
- ☒ Any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,


 Jeffrey A. Wyand, Reg. No. 29,458
 LEYD G. VOIT & MAYER
 700 Thirteenth Street, N.W., Suite 300
 Washington, DC 20005-3960
 (202) 737-6770 (telephone)
 (202) 737-6776 (facsimile)

Date: October 27, 2003
 JAW/tps
 Amendment or ROA Transmittal (Revised 10/2/03)



RECEIVED

OCT 28 2003

PATENT
Attorney Docket No. 401479

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

IZUO et al.

Application No. 10/009,521

Art Unit: 1742

Examiner: D. Valentine

Filed: December 11, 2001

For: ELECTROCHEMICAL ETCHING
METHOD AND APPARATUS AND
PRODUCT MANUFACTURED
THEREBY

RESPONSE TO OFFICE ACTION

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 4, 2003, please enter the following amendments and consider the following remarks.